

## United States Patent and Trademark Office

## \*BIBDATASHEET\*

Bib Data Sheet

**CONFIRMATION NO. 1239** 

SERIAL NUMB 10/602,072	SERIAL NUMBER 10/602,072 RULE		CLASS 438		GROUP ART UNIT 1765		ATTORNEY DOCKET NO. 04329.2470-01		
APPLICANTS									
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** CONTINUING DATA **********************************									
** FOREIGN APPLICATIONS ************************************									
IF REQUIRED, FOREIGN FILING LICENSE GRANTED ** 09/09/2003									
Foreign Priority claime		yes ono Metaft	ter	STATE OR	SHE	SHEETS		AL	INDEPENDENT
Verified and A. Huzoken F.H. COUL				COUNTRY JAPAN			CLAI 20		CLAIMS 3
ADDRESS 22852 FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER LLP 1300   STREET, NW WASHINGTON, DC 20005									
TITLE Dry etching method and semiconductor device manufacturing method									
						□ All	Fees		
- 3							6 Fees (	( Filing	)
	FEES No	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT					7 Fees (	(Proce	essing Ext. of